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R. Steiner

U.S. PRO  
09/813834

03/22/01

Applicant(s): ROH, Jae-Sung; YANG, Woun-S

Serial No.:

Group:

Filed: September 16, 1997

Examiner:

For: SEMICONDUCTOR DEVICE AND METHOD FOR MANUFACTURING THE SAME

LETTER

Assistant Commissioner for Patents  
Box Patent Application  
Washington, D.C. 20231

September 16, 1997  
0465-0369P

Sir:

Under the provisions of 35 USC 119 and 37 CFR 1.55(a), the applicant hereby claims the right of priority based on the following application(s):

<u>Country</u>	<u>Application No.</u>	<u>Filed</u>
REPUBLIC OF KOREA	73475/1996	12/27/96

A certified copy of the above-noted application(s) is(are) attached hereto.

Please charge any fees under 37 CFR 1.16 - 1.21 (h) or credit any overpayment to Deposit Account No. 02-2448.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

By: 

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Attorney's Packet No. 465-369P  
ROH et al  
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1 of 1

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별첨 사본은 아래 출원의 원본과 동일함을 증명함.

This is to certify that the following application annexed hereto  
is a true copy from the records of the Korean Industrial  
Property Office.

출원번호 : 1996 년 특허출원 제 73475 호  
Application Number

출원년월일 : 1996 년 12 월 27 일  
Date of Application

출원인 : 엘지반도체주식회사  
Applicant(s)

199 7 년 3 월 31 일

특 허 청

COMMISSIONER

